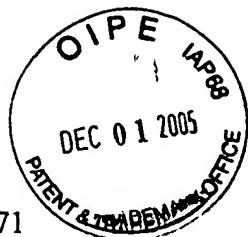


00862.023171



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKASHI ARAI) Examiner: Not Yet Assigned
Application No.: 10/634,860) Group Art Unit: 1731
Filed: August 6, 2003)
For: METHOD OF STORING)
MATERIAL INTO WHICH GAS)
SATURATES) November 30, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

This Information Disclosure Document is to make of record documents cited in a Japanese Office Action issued on September 5, 2005 in the priority application. A copy of the Office Action is also enclosed. In that connection, Applicant notes that the last four documents listed on the attached Form PTO-1449 were listed in the prior art search made by the Japanese Examiner and were applied in a rejection.

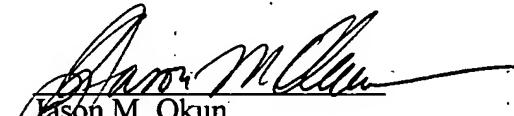
The concise explanation of relevance for the non-English language documents may be found, inter alia, in the English language abstracts attached thereto.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

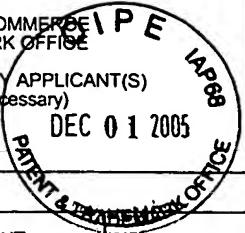
Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Jason M. Okun
Attorney for Applicant
Registration No. 48,512

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200



ATTY DOCKET NO.

00862.023171

APPLICATION NO.

10/634,860

APPLICANT

Takashi Arai

FILING DATE

August 6, 2003

GROUP

1731

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	2003-73496	03/12/03	Japan			Abstract
	JP	2000-327826	11/28/00	Japan			Abstract
	JP	60-166412	08/29/85	Japan			Abstract
	JP	10-279725	10/20/98	Japan			Abstract
	JP	11-293022	10/26/99	Japan			Abstract
	JP	10-36547	02/10/98	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1